

**SIEMENS**

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~~DO NOT ENTER: /M.G.M./~~

~~05/24/2008~~

*6.19.08*

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PATENT

Attorney Docket No. 2001P05854US02

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Inventor:	Ralf Buerger, et al.	)	Group Art Unit:	1792
Serial No.:	10/786,349	)	Examiner:	Michael G. Miller
Filed:	02/25/2004	)	Confirmation No.:	4552
Title:	METHOD FOR RESTORING THE MICROSTRUCTURE OF A TEXTURED ARTICLE AND FOR REFURBISHING A GAS TURBINE BLADE OR VANE			

MAIL STOP AF  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR 1.116

Sir:

In response to the Final Office Action mailed March 18, 2008 Applicants respectfully submit the following amendment and remarks in connection with the above-identified application.

Entry of this paper is respectfully requested in order to overcome the rejections under 35 USC 112. Reconsideration of the rejections under 35 USC 102 and 103 are respectfully requested in view of the Remarks provided below.

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